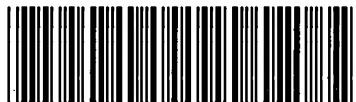


Search Notes**Application/Control No.**

10/629,543

Examiner

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Art Unit

2192

SEARCHED

Class	Subclass	Date	Examiner
717	168-173, 174	3/9/2006	CD
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711	102-104		
700	81		
713	2		

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Search for double patenting WEST - USPATFILE - USPGPUB - US OCR - JPO ABS - EPO ABS - DWPI - IBM TECH	3/9/2006	CD
ACM IEEE	3/9/2006	CD

INTERFERENCE SEARCHED

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